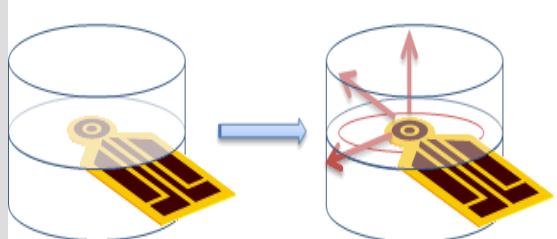


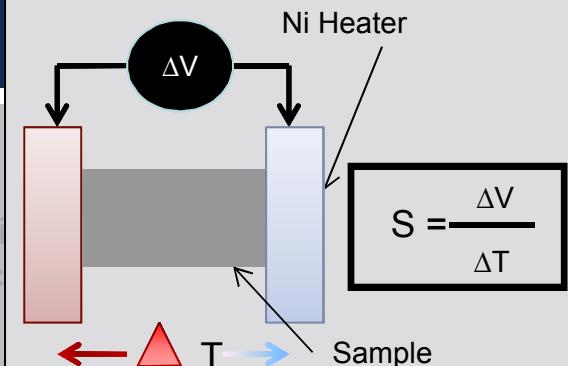
Exceptional service in the national interest



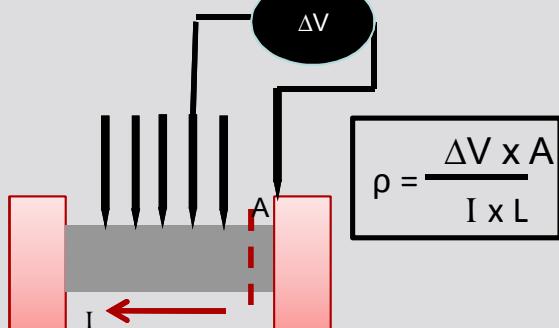
Thermal Conductivity
Thermal Diffusivity
Specific Heat



Seebeck Coefficient



Electrical Resistivity and Contact Resistance



Development of Transport Properties Characterization Capabilities for Thermoelectric Materials and Modules

Karla R. Reyes-Gil*, Josh Whaley, Ryan Nishimoto, and Nancy Yang

*corresponding author e-mail: krreyes@sandia.gov

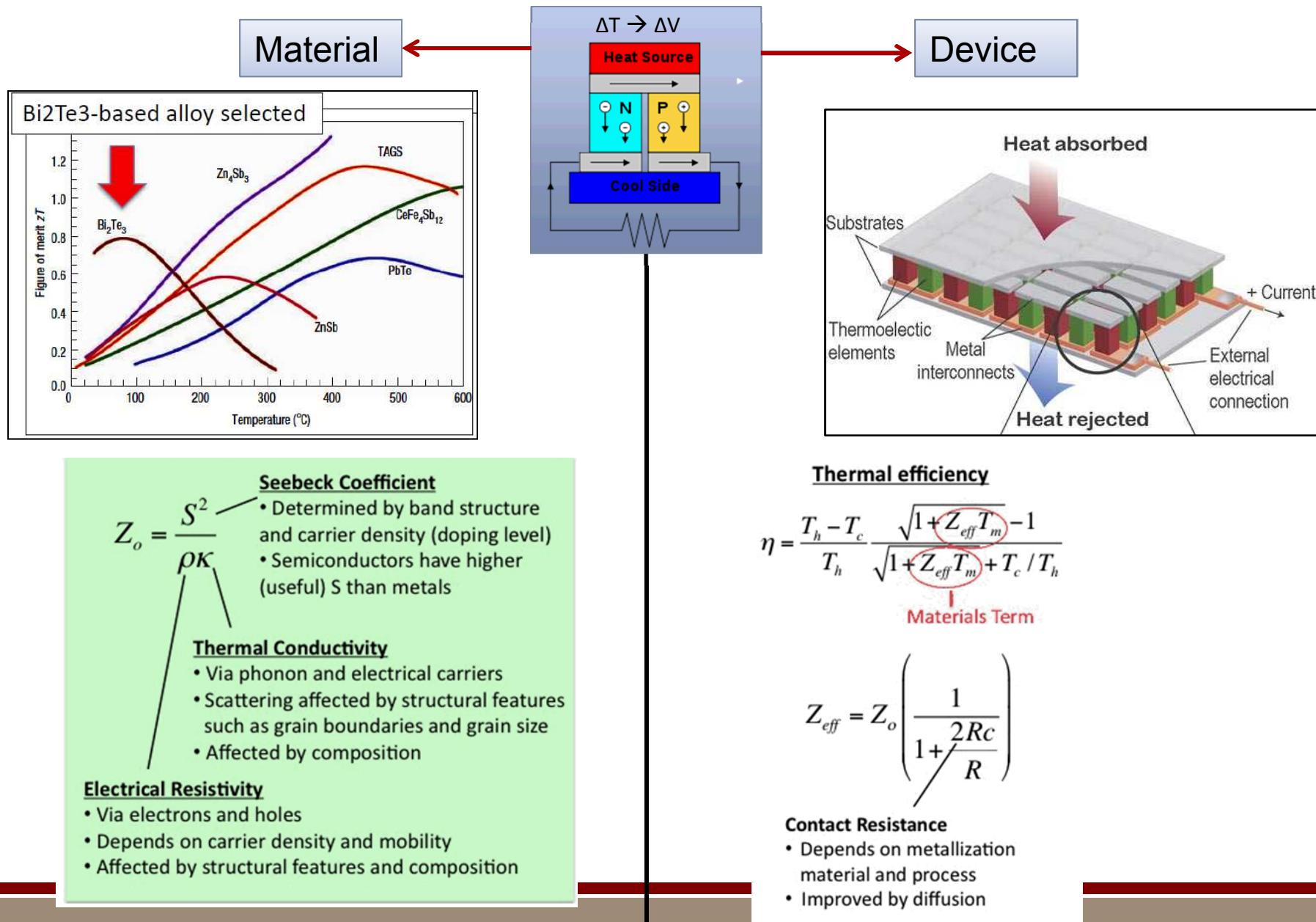
Materials Chemistry Department

Sandia National Laboratories, Livermore CA



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Thermoelectric figure of merit (Z_o and Z_{eff})



Challenges: Significant Measurements Issues

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INTERNATIONAL ROUND-ROBIN ON TRANSPORT PROPERTIES OF BISMUTH TELLURIDE

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IEA-AMT round-robin testing of n- and p-type bismuth telluride transport properties showed significant measurement issues and highlighted need for standardization of measurements of thermoelectric material properties



Hsin Wang

Oak Ridge National Laboratory
Oak Ridge, TN USA



<http://energy.gov/eere/vehicles/downloads/international-round-robin-transport-properties-bismuth-telluride>

MORE DOCUMENTS & PUBLICATIONS

[Reliability of Transport Properties for Bulk Thermoelectrics](#)

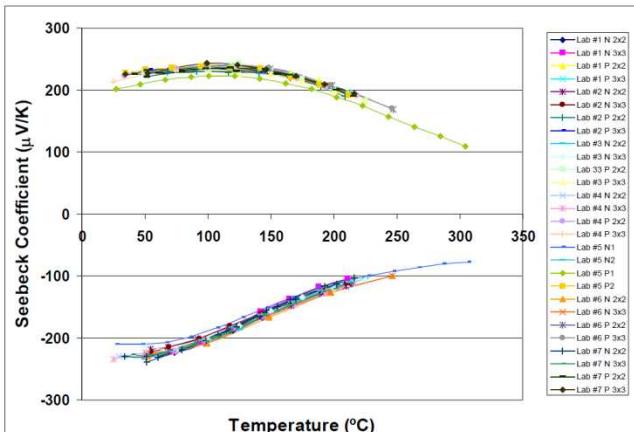
IEA-AMT Focus: Bulk Thermoelectrics Used for Automotive Waste Heat Recovery

- Significant gaps exist between literature ZT values and scalable materials
- Possible Issues:
 - Measurement errors
 - No standards for calibration
 - Incomplete measurements
 - Data extrapolation
 - Materials non-uniformity
 - Orientation effect
 - Measurements on different samples



Findings: Error for ZT from 12 to 21%

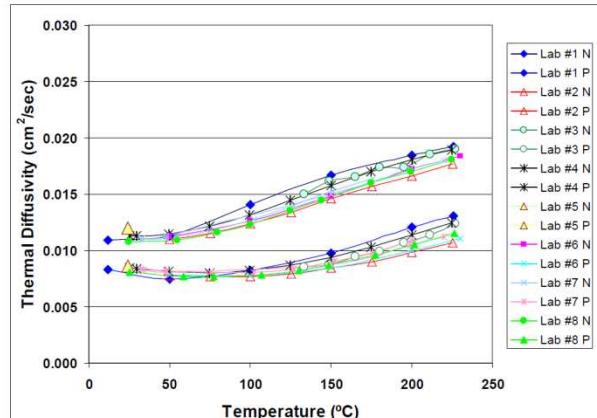
Round-robin 1: Seebeck Coeffieicnt



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Round-robin 1: Thermal Diffusivity

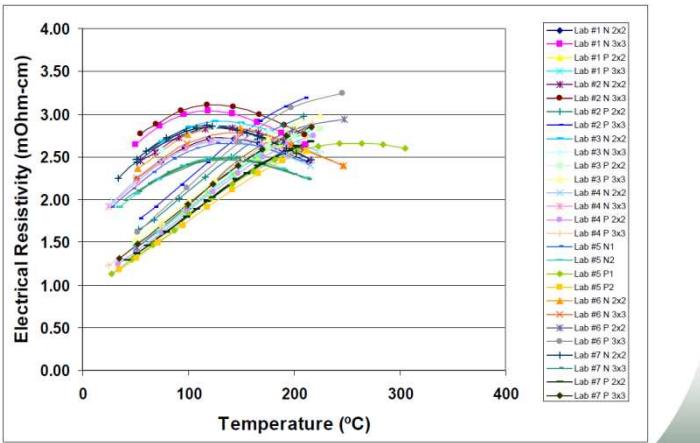


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Results from 8 labs



Round-robin 1: Electrical Resistivity



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Summary

- IEA-AMT is addressing the important issue of measurement standardization of thermoelectrics
- Significant measurement issues were observed, especially in specific heat and electrical resistivity.
- Good agreements in Seebeck coefficient, electrical resistivity
- Thermal diffusivity in good agreement expect for one test (data analysis)
- Specific heat remains an issue for reliable ZT
- Round-robin 3 underway
- Overall errors for ZT are from $\pm 12\%$ to 21%

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Development of Thermoelectric Characterization Capabilities at SNL

- Phase I: Instrumental Development and Standardization
 - Figure of merit (Z_o and Z_{eff}) is calculated as function of temperature

$$Z_o = \frac{S^2}{\rho \cdot \kappa}$$

- Seebeck coefficient (S)

- Electrical resistivity (ρ)

- Thermal conductivity (κ)

- Contact Resistance (R_c)

$$Z_{eff} = Z_o \left(\frac{1}{1 + \frac{2R_c}{R}} \right)$$

- Phase II: Material thermal aging studies

- Isothermal aging of Bi₂Te₃-based Alloys up to 2 year
- Effect in Z_o and Z_{eff}

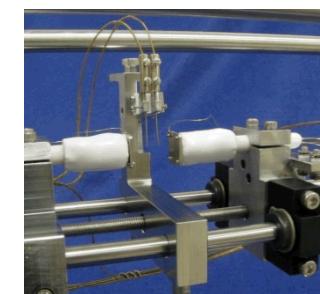
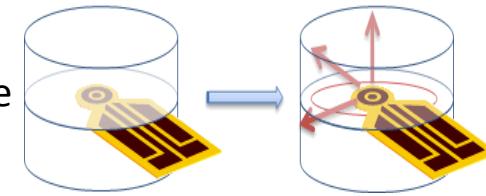
- Phase III: Advanced Characterization

- Non-destructive characterization of TE devices
- Realistic conditions: Temperature gradient and applied current
- Abnormal environments

Phase I: Commercial and custom built systems

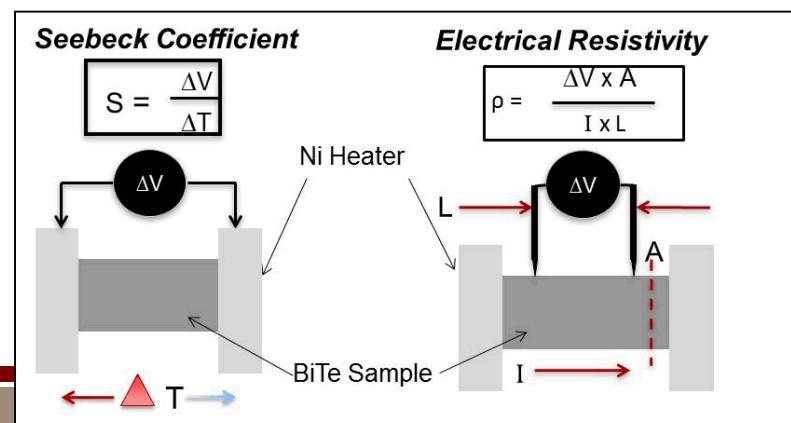
■ Commercial device:

- **TPS 2500S Thermal Property System:** Advanced system for testing the **thermal conductivity, thermal diffusivity** and **specific heat**.
- Hot Disk sensor is used both as a heat source and as a dynamic temperature sensor.
- The heat generated dissipates through the sample on either side at a rate dependent on the thermal transport characteristics of the material.
- By recording the temperature versus time response in the sensor, thermal conductivity can accurately be calculated.



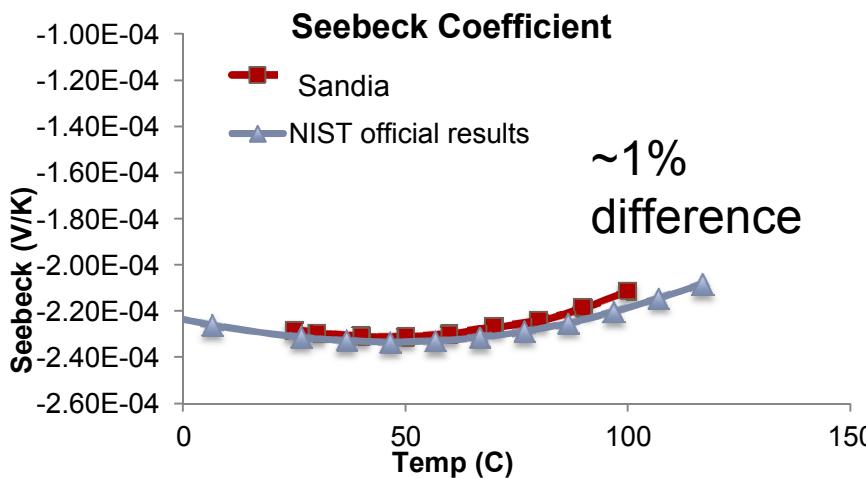
■ Custom-built device for **Seebeck/Resistivity** measurements

- To measure resistivity, the sample is located between two heaters with two voltage probes in contact with the top surface. A known current is then sent through the material and a voltage recorded.
- To measure Seebeck, a temperature gradient is set up across the material and the voltage recorded.



Standardization

■ NIST Standard for Seebeck Coefficient



National Institute of Standards & Technology

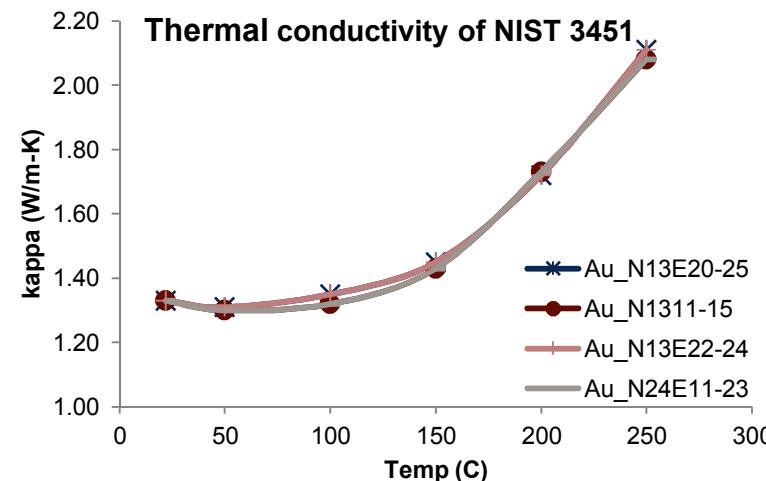
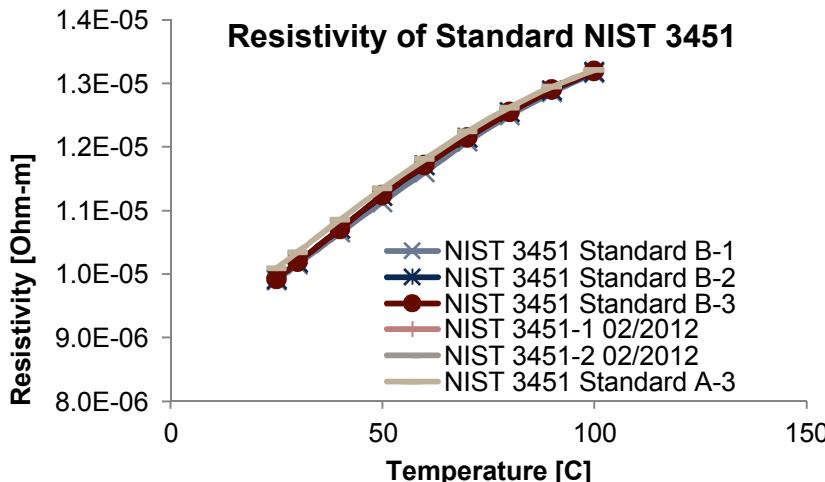
Certificate

Standard Reference Material® 3451

Low-Temperature Seebeck Coefficient Standard (10 K to 390 K)

- Variation Coefficient is < 1% for all the measurements.
- The data is reproducible over one year.
- NIST standard is used as reference and it is measured periodically.

■ No NIST standard for resistivity or thermal conductivity

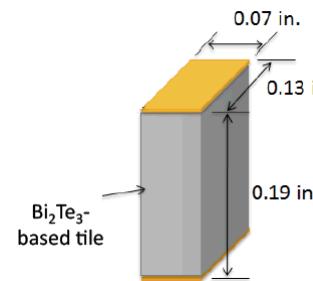


Phase II: Thermal Aging Studies

Base TE Material Diffusion Barrier Aging Temperature Aging Period

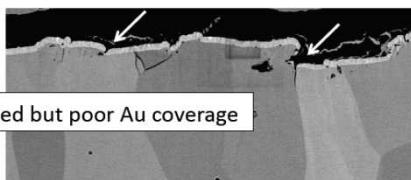
p-type Bi-Te	Electroless Ni	100 ° C	2 weeks
n-type Bi-Te	Electroless Co	175 ° C	8 weeks
	Electrolytic Co	240 ° C	Six months
	Electroless Pd	350 ° C	1 year
	Electrolytic Pd		2 years

2 weeks
8 weeks
Six months
1 year
2 years

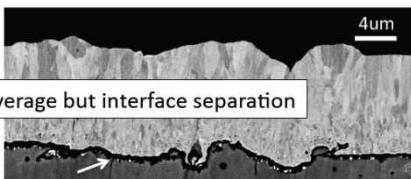


Today's Focus

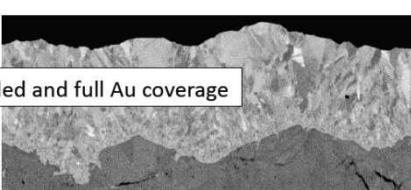
PVD/sputter Au



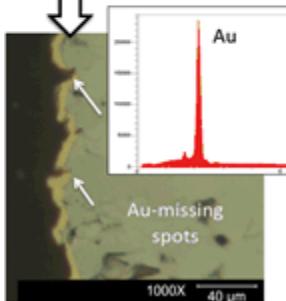
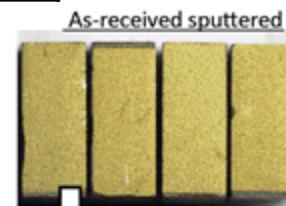
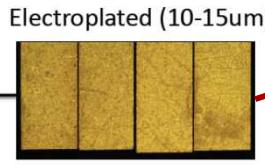
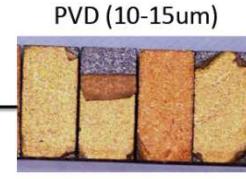
Well bonded but poor Au coverage



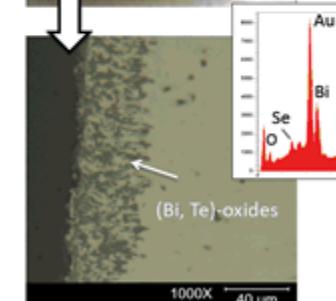
Full Au coverage but interface separation



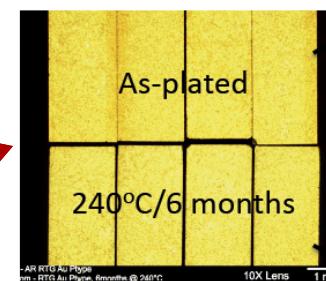
Well bonded and full Au coverage



1000X 40 μm



1000X 40 μm

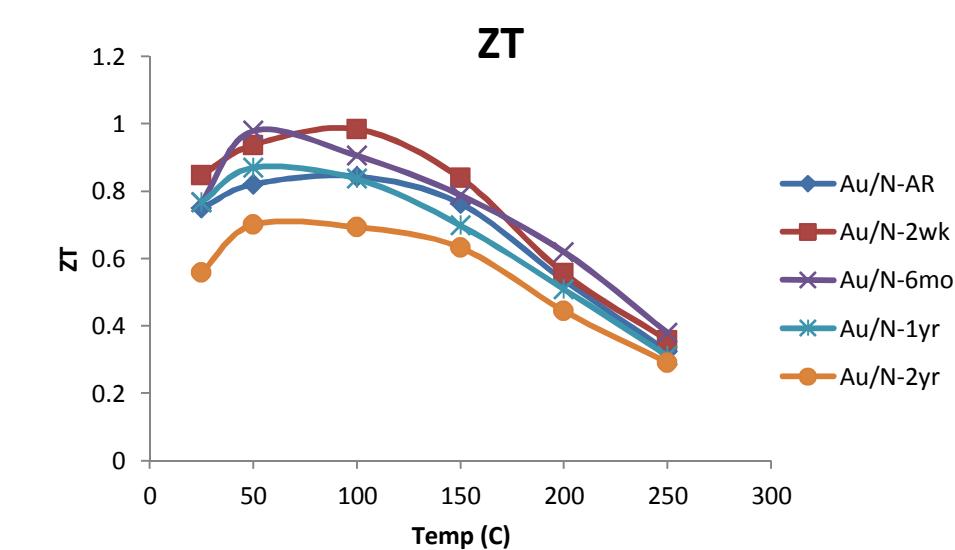
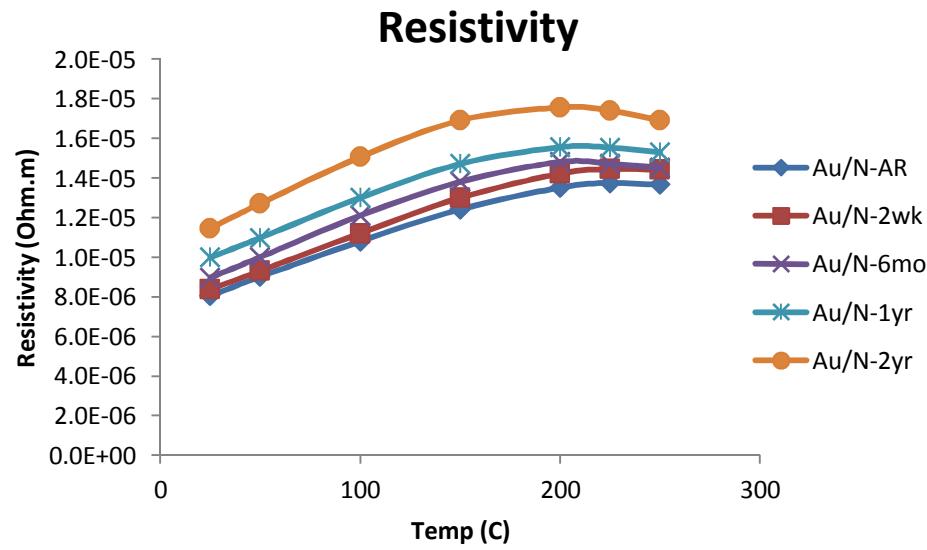
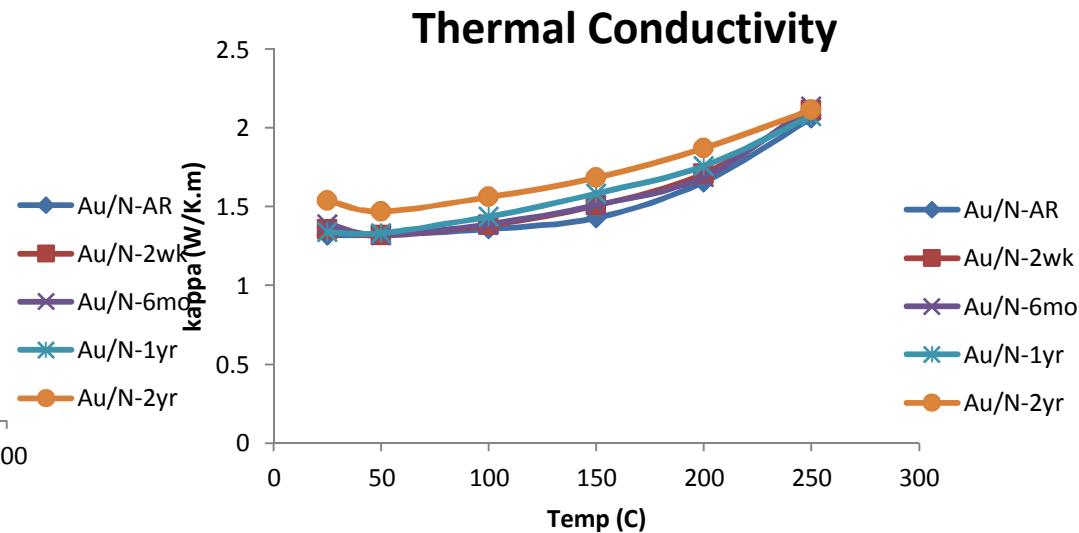
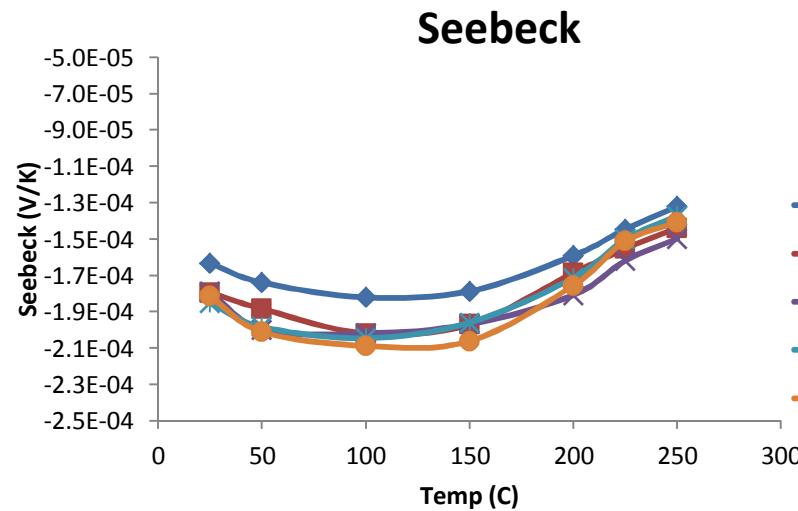


240°C/6 months

No Surface oxidation or interfacial reaction

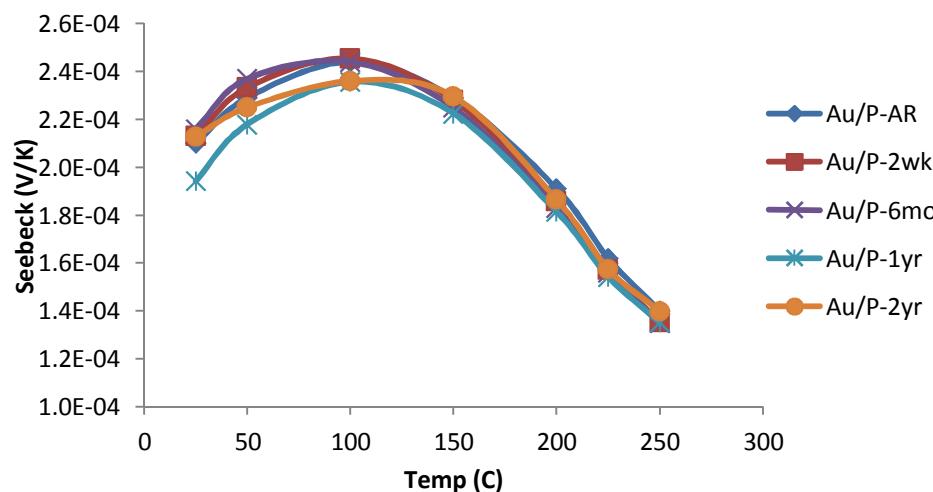
Transport properties changes????

TE transport properties for the n-type aged up to 2 yr @ 240°C

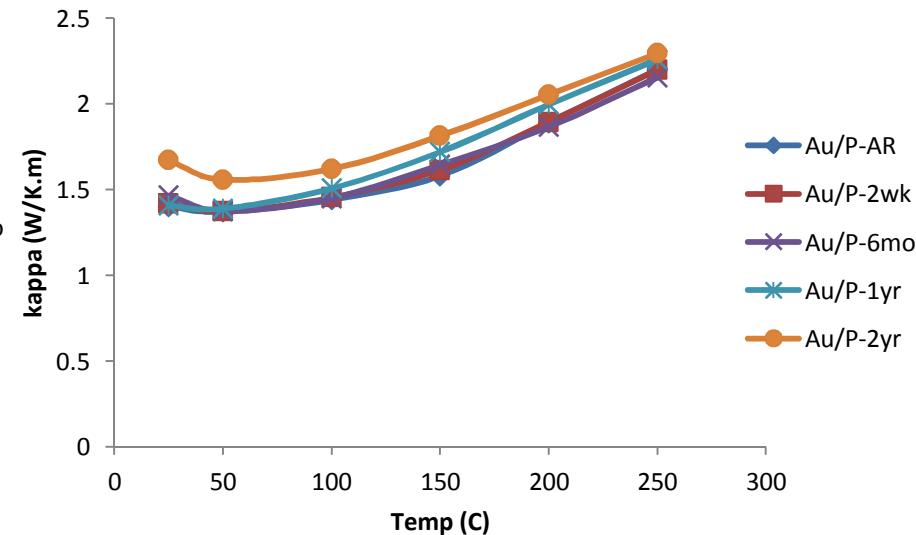


TE transport properties for the p-type aged up to 2 yr @ 240°C

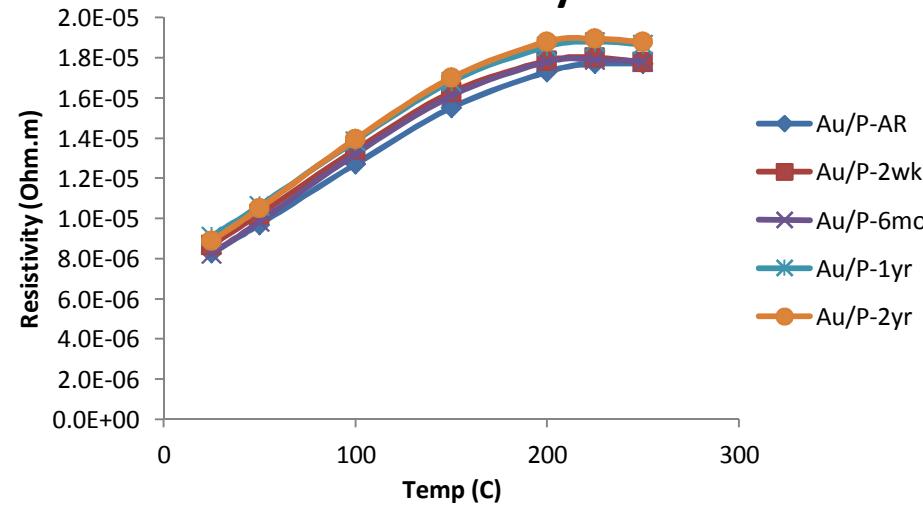
Seebeck



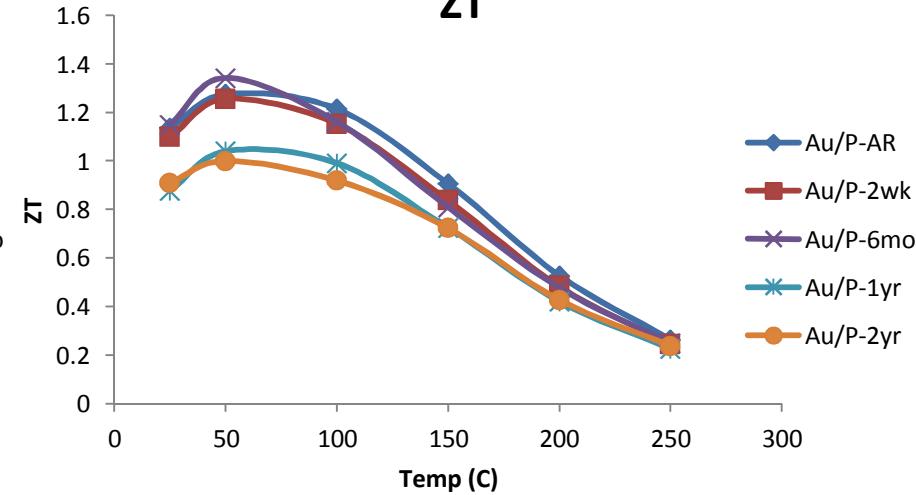
Thermal Conductivity



Resistivity



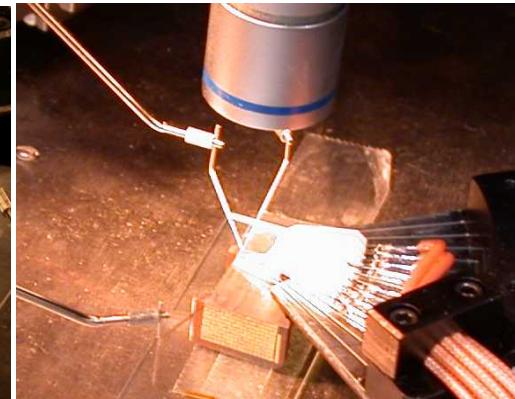
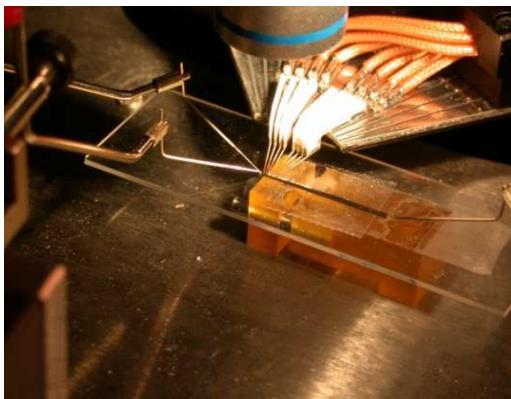
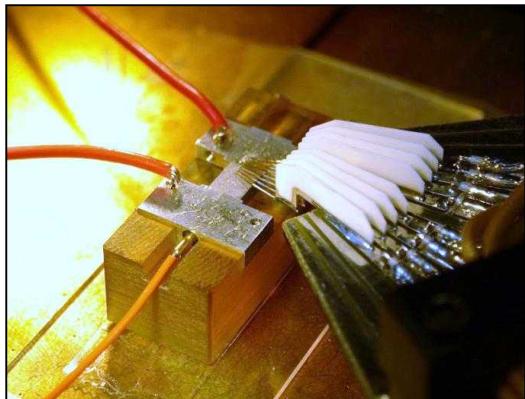
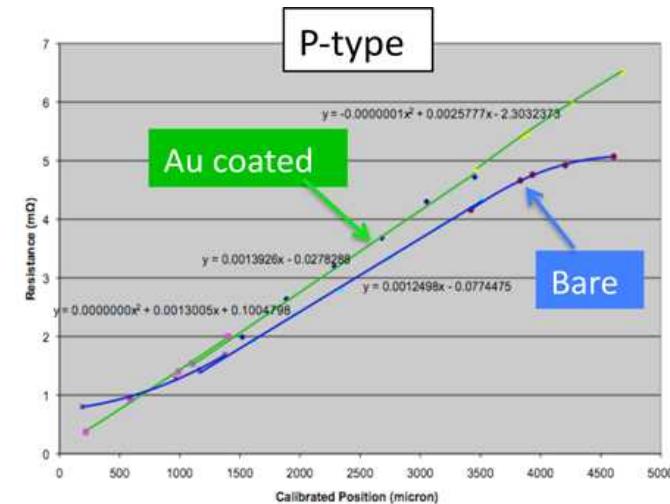
ZT



Phase III: Advanced Characterization

- Contact resistance and bulk resistivity measurements by 4-point probe method using custom built in-house device
- current is injected across two faces of the sample while voltage measurements are taken at equal distances (400 μ m) on the top face

slope \rightarrow resistivity y-intercept \rightarrow contact resistance



Original setup to measure tiles

New setup to measure thin elements

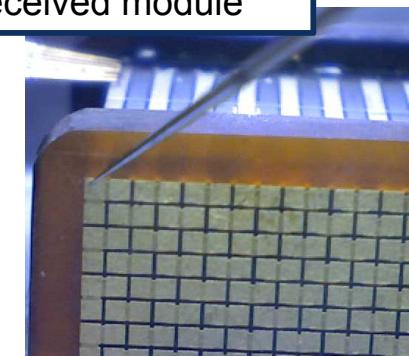
Modified setup to measure TE Modules

- Sample size limitation
- Fixed setup
- Sample size flexibility
- 2D adjustable probes
- Samples: thin elements (cross section = 0.25 mm²) with any lengths.

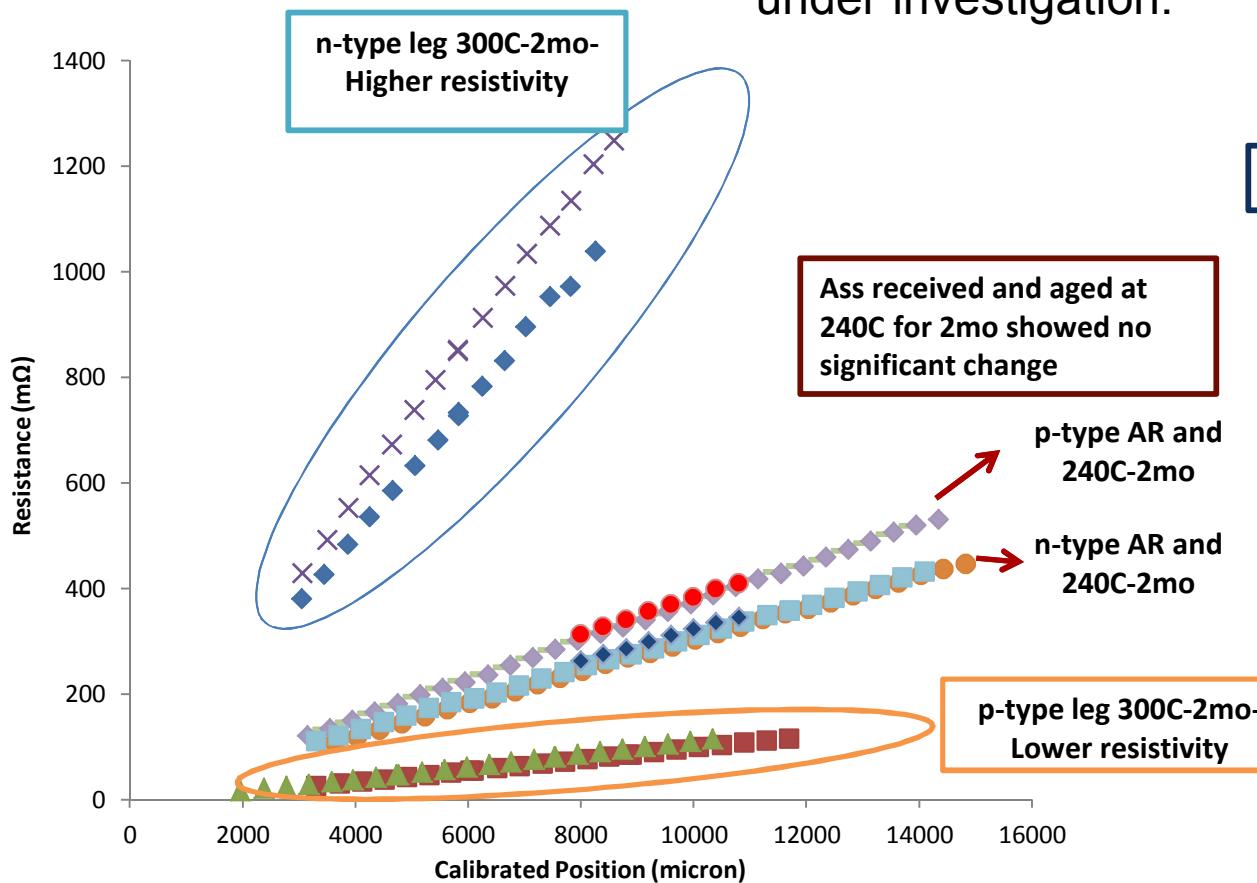
- Front/rear cameras for 3D adjustments
- Samples: TE modules
- Contact resistance of metallization on the hot and the cold end.

Resistivity changes of modules at abnormal temperature

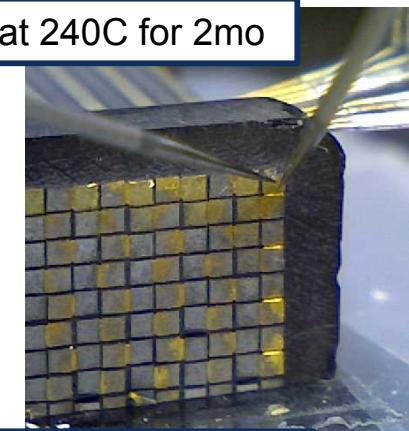
As received module



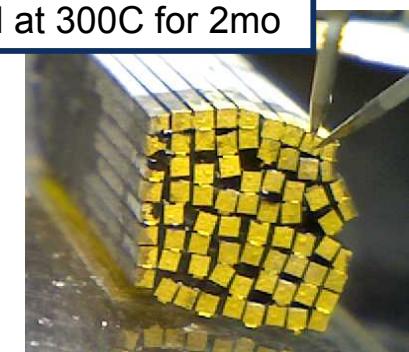
The resistivity changes at abnormal temperatures are under investigation.



Aged at 240C for 2mo



Aged at 300C for 2mo



Summary

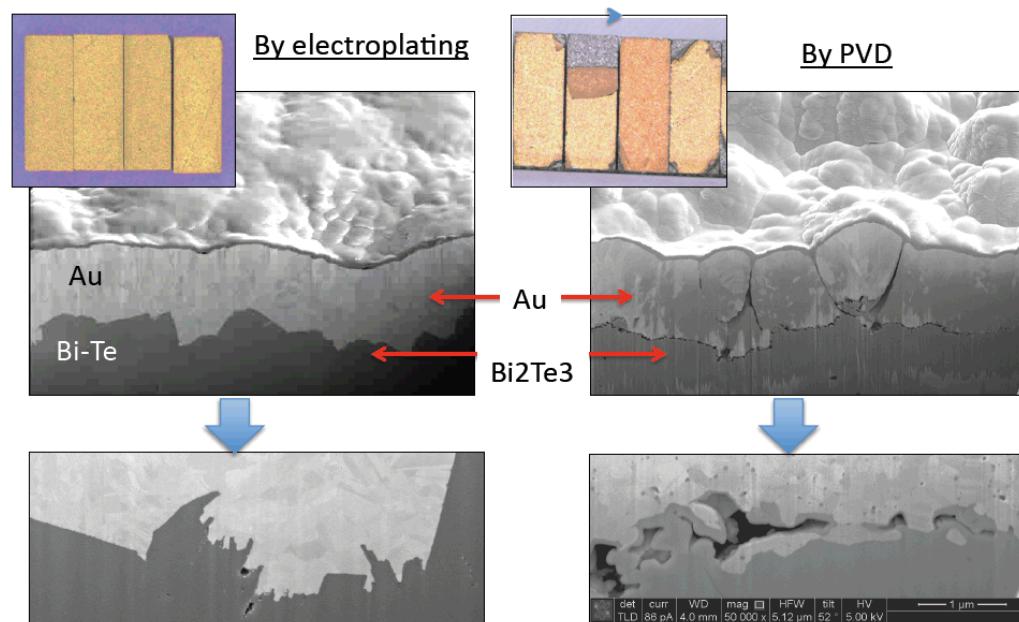
- International Round-Robin study found that significant measurements issues and 12-21% differences on ZT values.
- Sandia has dedicated several years on the development of reliable and reproducible in-house thermoelectric characterization capabilities.
- Sandia has conducted thermal aging studies up to 2yr to determine how the performance of the bulk material and metallization changes with aging time and temperature.
 - Electroplated Au metallization is thermal stable
 - Bulk Bi_2Te_3 -based alloys showed a change in transport properties (in particular in resistivity) after 2 yr aging.
- Advanced instrumentation makes possible the non-destructive analysis of thermoelectric modules.
- Based on the resistivity changes, we are conducting further studies to determine the root causes of these changes.

Acknowledgements

- Coauthors: Nancy Yang, Jeff Chames, Ryan Nishimoto and Josh Whaley
- Peter Sharma and Alf Morales
- Sandia CA and NM
- Dale Hume, president of Thermtest, Inc.

Questions?

Extras

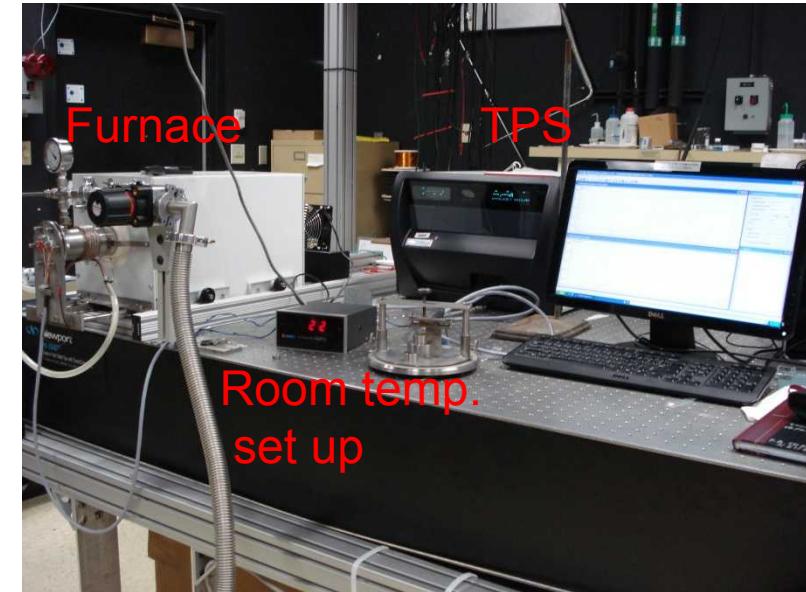
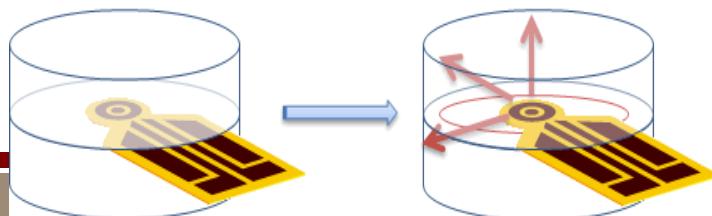


The plated-in Au provides good mechanical locking for adhesion

The PVD Au is unable to fill the surface defect to provide mechanical locking.

Thermal Conductivity measurement procedure

- Hot Disk Sensor- consists of an electrically conducting pattern of a thin sheet of Nickel.
- Hot Disk sensor is fitted between two pieces of the sample each one with a plane surface facing the sensor.
- Hot Disk sensor is used both as a heat source and as a dynamic temperature sensor.
 - Apply an electrical current, high enough to increase the temperature of the sensor between a fraction of a degree up to several degrees.
 - At the same time recording the resistance (temperature) increase as a function of time.
- The heat generated dissipates through the sample on either side at a rate dependent on the thermal transport characteristics of the material.
- By recording the temperature versus time response in the sensor, thermal conductivity can accurately be calculated.

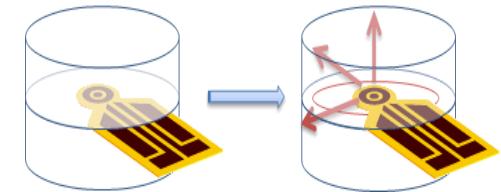


TPS 2500S Thermal Property System

- Advanced system for testing the thermal conductivity, thermal diffusivity and specific heat of solids, liquids, pastes & powders.
- Accuracy: Better than 5%
- Repeatability: Typically better than 1%
- Thermal Conductivity : 0.005 to 500 W/mK
- **New system**- low temperature test cell and bath (s) for -40 to 200 / 300C.

TPS 2500S Thermal Property System

- Hot Disk Sensor- consists of an electrically conducting pattern of a thin sheet of Nickel.
- Hot Disk sensor is fitted between two pieces of the sample each one with a plane surface facing the sensor.
- Hot Disk sensor is used both as a heat source and as a dynamic temperature sensor.
 - Apply an electrical current, high enough to increase the temperature of the sensor between a fraction of a degree up to several degrees.
 - At the same time recording the resistance (temperature) increase as a function of time.
- The heat generated dissipates through the sample on either side at a rate dependent on the thermal transport characteristics of the material.
- By recording the temperature versus time response in the sensor, thermal conductivity can accurately be calculated.
- The Thin Film Module allows for thermal conductivity measurements on single layer thin films and coatings.



Specifications

TC: 0.005 - 10 W/(mK)

Temp: -160 to 300 °C

Repeatability: Typically better than 3%

Sample thickness: 0.01 - 2 mm

Seebeck Coefficient and Resistivity Measurement

The custom built in-house device has been used to measure the Seebeck coefficient and electrical resistivity of thermoelectric materials within the temperature range of 22 ° C to 350 ° C.

- To measure resistivity, the sample is located between two heaters with two voltage probes in contact with the top surface. A known current is then sent through the material and a voltage recorded.
- To measure Seebeck, a temperature gradient is set up across the material and the voltage recorded.

